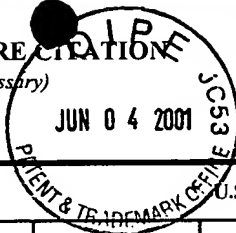


INFORMATION DISCLOSURE STATEMENT
(Use several sheets if necessary)



Docket Number (Optional) 1382/005	Application Number
Applicant(s) Lebouitz et al.	
Filing Date April 19, 2001	Group Art Unit

U.S. PATENT DOCUMENTS

#2

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
pl	—	4,415,402	11/15/83	Gelernt et al.			
pl	—	5,200,023	04/06/93	Gifford et al.			
pl	—	5,726,480	03/10/98	Pister			
pl	—	5,807,761	09/15/98	Coronel et al.			
pl	—	5,877,032	03/02/99	Guinn et al.			
pl	—	5,877,407	03/02/99	Cadet et al.			
pl	—	5,939,886	08/17/99	Turner et al.			

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	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
pl	—	EP 0 878 824 A2	11/18/98	European Patent Office				
pl	—	02187025	07/23/90	Japan				
pl	—	11145067	05/28/99	Japan				
pl	—	11204509	07/30/99	Japan				
pl	—	11265878	09/28/99	Japan				

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

pl	—	H.F. Winters and J. W. Coburn, "Etching of Silicon with XeF2 Vapor," App. Phy. Lett., Vol. 34, No. 1, pp. 70-73, Jan. 1979.
pl	—	S.J. Sherman, W.K. Tsang, T.A. Core, D.E. Quinn, "A Low Cost Monolithic Accelerometer," 1992 Symposium on VLSI Circuits, Digest of Technical Papers, Seattle, WA, USA, pp. 34-35, June 4-6, 1992.

EXAMINER P. Hassan coded	DATE CONSIDERED 3-6-03
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

INFORMATION DISCLOSURE CITATION
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Docket Number (Optional) 1382/005	Application Number
Applicant(s) Lebouitz et al.	
Filing Date April 19, 2001	Group Art Unit

PATENT DOCUMENTS

#2

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

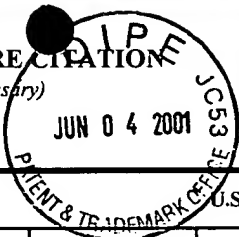
<i>pt</i>	—	P.B. Chu, J.T. Chen, R. Yeh, G. Lin, J.C.P. Huang, B.A. Warneke, and K.S.J. Pister, "Controlled Pulse-Etching with Xenon Difluoride," Transducers 1997, Chicago, IL, pp. 16-19, June 1997.
<i>pt</i>	—	English language abstract of Japanese publication number 02187025, Patent Abstracts of Japan. 7-23-1990

EXAMINER P. Hassan zodeh	DATE CONSIDERED 7-6-07
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Docket Number (Optional)
1382/005

Application Number
09/839,763

Applicant(s)
Leboutiz et al.

Filing Date
April 20, 2001

Group Art Unit

U.S. PATENT DOCUMENTS

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*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

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12L	—	English language abstract of Japanese publication number 11145067, Patent Abstracts of Japan, 5-28-1990
12L	—	English language abstract of Japanese publication number 11204509, Patent Abstracts of Japan, 7-30-1999

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DATE CONSIDERED
3-6-07

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SHEET 4 OF 4

(Use several sheets if necessary)

1382/005

09/839,763

Applicant(s)

Lebouitz et al.

Filing Date

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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

ph — English language abstract of Japanese publication number 10209088, Patent Abstracts of Japan. Aug. 7, 1998

EXAMINER

P. Hassan-zadeh L

DATE CONSIDERED

3-6-05

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